The metamaterial was manufactured by focused ion beam milling on a 50 nm thick silicon nitride membrane that provides a stable and flexible base for the metallic pattern. The metallic pattern, which is predominantly responsible for resonant optical properties of the whole structure, consists of a meander design alternating with straight metal wires. The meander pattern provides a resonant response linked to the excitation of a plasmonic mode (Fig. 1d). The variable distance between the straight wire and the meander-shaped conductor controls the resonant optical response.
of the nanostructure. Control over this spacing is achieved by manufacturing the 50 nm thick straight and meander gold wires on different flexible bridges that were cut from the silicon nitride membrane. The 500 nm and 230 nm wide bridges were separated by 125 nm gaps to provide room for relative motion and the ends of the bridges were narrowed to increase flexibility as shown on the SEM image. In order to make the bridge spacing adjustable, pairs of bridges were alternatingly connected to two electrical terminals of the device, which allow the electrostatic forces between the bridges to be controlled (Fig. 1b). The section of the metamaterial pattern that was available for optical modulation was 12 x 25 microns in size.

![Diagram](image)

**Fig. 2.** Electro-optic modulator and switch. (a) Schematic of the electro-optical modulator. (b) Switching contrast between the metamaterial’s “on” and “off” states in terms of relative transmission and reflection changes, $\Delta T/T_{\text{on}}$ and $\Delta R/R_{\text{on}}$. (c) Scanning electron microscope image of the metamaterial in its switched “on” state.

For applied voltages of up to ~6V, the spacing between the bridges can be continuously controlled as the restoring force of the elastic structure can balance the electrostatic forces between the bridges. This allows continuous tuning and modulation of the metamaterial properties. Measurements of the metamaterial’s transmission at a wavelength of 1.3 $\mu$m show that its optical properties can be controlled with modulation frequencies of up to about 10 MHz.

Non-volatile switching occurs at ~6V, when the electrostatic force overcomes the elastic restoring force of the silicon nitride bridges. Here, the structure switches into a bridge-pair configuration (Fig. 2c), leading to a dramatic 20% red-shift of the metamaterial’s spectral response and relative transmission changes of up to 90% (Fig. 2b).

In summary, we demonstrate fast electro-optical modulation and high-contrast switching with an electrostatically actuated NEMS photonic metamaterial that has megahertz bandwidth.